



Attorney Docket No. 21.1837
CJC

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Munetaka TAKEUCHI, et al.

Application No.: 08/889,440

ATTENTION

Confirmation No.: 3473

CERTIFICATE OF CORRECTION

Filed: July 8, 1997

BRANCH

U.S. Patent No.: 7,231,332

Issued: June 12, 2007

For: APPARATUS AND METHOD FOR SIMULATING PHENOMENA OF A PARTICLE OF SUBSTRATE PARTICLES AND ADSORBATE PARTICLES

REQUEST FOR CERTIFICATE OF CORRECTION

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Patentees respectfully request that a Certificate of Correction be issued in the subject patent, pursuant to 35 U.S.C. §254 and 37 C.F.R. §1.322, to correct the mistakes shown on the attached Form PTO-1050.

Since the mistakes are Patent Office mistakes, it is believed that no fee is required.

Respectfully submitted,

STAAS & HALSEY LLP

Date: Sept. 5, 2007

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SEP 07 2007
Certificate
of Correction

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UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO : 7,231,332

DATED : June 12, 2007

INVENTOR(S) : Munetaka TAKEUCHI, et al.

First Page, Column 2 (Other Publications), Line 6, change "Electron-Imapct" to
--Electron-Impact--.

Column 18, Line 35, after "wherein" delete "p1".

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PATENT NO. 7,231,332No. of add'l copies
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